TRA	NSMITTAL O	Docket No. H0004803										
in Re Application Of: Richard W. Gehman, et al.												
	Serial No.	Filing Date	Examiner	Group Art Unit								
Not	Yet Assigned	Not Yet Assigned	Not Yet Assigned	Not Yet Assigned								
Title: Tamper Resistant Vapor Sensor Method and System												
	Address to:  Commissioner for Patents  P.O. Box 1450  Alexandria, VA 22313-1450											
	37 CFR 1.97(b)											
1. 🛚	The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.											
		37 C	CFR 1.97(c)									
2.	CFR 1.97(b), pr Final Action un	The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:										
	☐ the stater	nent specified in 37 CFR 1.97(e);	;									
		OR										
	☐ the fee se	et forth in 37 CFR 1.17(p).										

## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number			
H0004803	Not Yet Assigned			
Applicant(s) Richard W. Gehman, et al.				
Filing Date	Group Art Unit			
	1			

	Not Yet Assigned							Not Yet Assigned			
U.S. PATENT DOCUMENTS											
*EXAMINER INITIAL	REF		DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE  IF APPROPRIATE		
		US	2001/0038986 A1	11/08/2001	Abrahai	n, et al.	431	22	04/04/2001		
		US	6,626,133 B2	09/30/2003	Schell et	al.	122	504	05/31/2002		
		US	6,622,661 B1	09/23/2003	Hotton		122	13.01	01/16/2003		
		US	6,540,504 B2	04/01/2003	Kobayashi et al.		431	77	04/10/2002		
		US	6 6,412,447 B1 07/02/20		Trant et al.		122	14.21	04/16/2001		
		US	6,390,028 B1	05/21/2002	Langmead et al.		122	14.2	03/12/2001		
		US	6,198,295 B1	03/06/2001	Hill		324	711	01/06/1999		
FOREIGN PATENT DOCUMENTS											
	REF	DOCUMENT NUMBER		DATE		COUNTRY	CLASS	SUBCLASS	Translation YES NO		
									120		
					OTHER I	OOCUMENTS (Including A	tuthor, Title, D	ite, Pertinent Pa	iges, Etc.)		
EXAMINER DATE CONSIDERED											
			<del></del>			<del></del>			_		

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.